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## APPLICANTS

Kwang-Ok Koh, Gyeonggi-do, KOREA, REPUBLIC OF;

Kun-Ho Kwak, Gyeonggi-do, KOREA, REPUBLIC OF;

Byung-Jun Hwang, Gyeonggi-do, KOREA, REPUBLIC OF; Han-Soo Kim, Gyeonggi-do, KOREA, REPUBLIC OF;

\*\* CONTINUING DATA \*\*\*\*\* *None* ✓\*\* FOREIGN APPLICATIONS \*\*\*\*\* *Yes* ✓

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## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 03/16/2004

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 11	TOTAL CLAIMS 21	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after <i>Allowance</i>				
Verified and Acknowledged	<i>[Signature]</i>	<i>lv</i>			

## ADDRESS

20792  
 MYERS BIGEL SIBLEY & SAJOVEC  
 PO BOX 37428  
 RALEIGH , NC  
 27627

## TITLE

Methods of forming semiconductor devices using an etch stop layer

All Fees